IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:)	
		:	Examiner: K.J. Ramsey
SHUJI AOKI ET AL.)	•
		:	Group Art Unit: 2879
Application No.: Division)	•
	of U.S. Patent Appln.	:	
	No. 10/209,876)	
		:	
Filed: Herewith)	
		:	
For:	METHOD AND APPARATUS FOR)	
	ADJUSTING CHARACTERISTICS	:	
	OF ELECTRON SOURCE, AND)	
	METHOD FOR MANUFACTURING	:	
	ELECTRON SOURCE)	February 9, 2004
Mail Stop			
Commissioner for Patents			
P.O. Box 1450			
Alexandria, VA 22313-1450			

PRELIMINARY AMENDMENT AND INFORMATION DISCLOSURE STATEMENT

Sir:

Preliminary to examination, please amend the above-identified application, filed herewith, as follows: